

Notice of References Cited	Application/Control No. 10/783,523	Applicant(s)/Patent Under Reexamination LEE, KUO SHENG	
	Examiner Angela M. Lie	Art Unit 2821	Page 1 of 1

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	B	US-6,307,324	10-2001	Hirano et al.	315/169.3
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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